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**TRANSMITTAL LETTER**  
**(General - Patent Pending)**

Docket No.  
**SEC.828D**

In Re Application of Ju-Cheol SHIN et al.

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/601,561	June 24, 2003	Karla A. Moore	20987	1763	7739

Title: **CHEMICAL VAPOR DEPOSITION METHOD FOR DEPOSITING SILICIDE AND APPARATUS FOR PERFORMING THE SAME**

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

**Reply to Notice of Non-Compliant Amendment**  
**Abstract in Clean Text (No Markings)**

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☐ The Director is hereby authorized to charge and credit Deposit Account No. \_\_\_\_\_ as described below.
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Signature

Dated: **MARCH 3, 2005**

**STEPHEN R. WHITT, PLLC**  
**REG. NO. 34,753**

**VOLENTINE FRANCOS & WHITT, PLLC**  
**ONE FREEDOM SQUARE**  
**11951 FREEDOM DRIVE, SUITE 1260**  
**RESTON, VA 20190**  
**TEL. NO. 571.283.0720**

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CC:



Application No. 10/601,561  
Attorney Docket No. SEC.828D  
Amendment Filed March 3, 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of :  
Ju-Cheol SHIN et al. : Group Art Unit: 1763  
Application No. 10/601,561 : Examiner Karla A. Moore  
Filed: June 24, 2003 :

For: CHEMICAL VAPOR DEPOSITION METHOD FOR DEPOSITING SILICIDE AND  
APPARATUS FOR PERFORMING THE SAME

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**Reply to Notice of Non-Compliant Amendment**

U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria VA 22314

Sir:

In response to the Notice of Non-Compliant Amendment of February 25,  
2005, please amend the above-identified application as follows:

**Amendments to the Abstract** begins on page 2 of this paper.

**Conclusion** begins on page 3 of this paper.